Notice of References Cited Application/Control No. 10/561,536 Examiner Vanessa T. Velasquez Applicant(s)/Patent Under Reexamination OISHI ET AL. Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2001/0055539	12-2001	Nakamura et al.	420/409
	В	US-			
	C	US-			
	D	US-			
	E	US-		:	
	F	US-			
	G	US-			
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FOREIGN PATENT DOCUMENTS

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